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CONFIRMATION NO. 3618

SERIAL NUMBER 09/696,813	FILING DATE 10/25/2000 RULE	CLASS 257	GROUP ART UNIT 2811	ATTORNEY DOCKET NO. SLA 0468	
APPLICANTS Apostolos Voutsas, Portland, OR; Yukihiko Nakata, Nara, JAPAN; Takeshi Hosoda, Vancouver, WA;					
** CONTINUING DATA <i>None K.N.</i>					
** FOREIGN APPLICATIONS <i>None K.N. Sharp laboratories of America, Inc.</i>					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/05/2001					
<input checked="" type="checkbox"/> Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>K. N.</i> Examiner's Signature Initials		STATE OR COUNTRY OR	SHEETS DRAWING 7	TOTAL CLAIMS 19	INDEPENDENT CLAIMS 6
ADDRESS David C Ripma Patent Counsel Sharp Laboratories of America Inc 5750 NW Pacific Rim Boulevard Camas ,WA 98607					
TITLE Semiconductor device and a method of creating the same utilizing metal induced crystallization while suppressing partial solid phase crystallization					
FILING FEE RECEIVED 950	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other <input type="checkbox"/> Credit			